

Title (en)  
SEMICONDUCTOR DEVICE

Title (de)  
HALBLEITERBAUELEMENT

Title (fr)  
DISPOSITIF À SEMI-CONDUCTEUR

Publication  
**EP 2280416 A1 20110202 (EN)**

Application  
**EP 09731627 A 20090413**

Priority  
• JP 2009057435 W 20090413  
• JP 2008105739 A 20080415

Abstract (en)  
A MOSFET (1) capable of achieving decrease in the number of steps in a manufacturing process and improvement in integration includes an SiC wafer (10) composed of silicon carbide and a source contact electrode (16) arranged in contact with the SiC wafer (10) and containing titanium, aluminum, silicon, and carbon as well as a remaining inevitable impurity. The SiC wafer (10) includes an n + source region (14) having an n conductivity type and a p + region (18) having a p conductivity type. Both of the n + source region (14) and the p + region (18) are in contact with the source contact electrode (16). The source contact electrode (16) contains aluminum and titanium in a region including an interface with the SiC wafer (10).

IPC 8 full level  
**H01L 29/45** (2006.01); **H01L 21/28** (2006.01); **H01L 21/336** (2006.01); **H01L 21/337** (2006.01); **H01L 29/78** (2006.01); **H01L 29/808** (2006.01); **H01L 29/16** (2006.01)

CPC (source: EP KR US)  
**H01L 21/0485** (2013.01 - EP KR US); **H01L 29/1608** (2013.01 - KR); **H01L 29/45** (2013.01 - EP KR US); **H01L 29/66068** (2013.01 - EP KR US); **H01L 29/66712** (2013.01 - KR); **H01L 29/7802** (2013.01 - EP KR US); **H01L 29/8083** (2013.01 - EP KR US); **H01L 29/1608** (2013.01 - EP US)

Cited by  
EP2434534A4; EP2866263A4

Designated contracting state (EPC)  
AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HR HU IE IS IT LI LT LU LV MC MK MT NL NO PL PT RO SE SI SK TR

Designated extension state (EPC)  
AL BA RS

DOCDB simple family (publication)  
**EP 2280416 A1 20110202**; **EP 2280416 A4 20121031**; **EP 2280416 B1 20150617**; CA 2721668 A1 20091022; CA 2721671 A1 20091022; CN 102007595 A 20110406; CN 102007595 B 20131225; CN 102007596 A 20110406; CN 102007596 B 20130102; EP 2280417 A1 20110202; EP 2280417 A4 20121107; EP 2280417 B1 20150722; JP 2014078735 A 20140501; JP 5477286 B2 20140423; JP 5522035 B2 20140618; JP 5741674 B2 20150701; JP WO2009128382 A1 20110804; JP WO2009128419 A1 20110804; KR 101442886 B1 20140919; KR 20100134009 A 20101222; KR 20100134038 A 20101222; TW 201007841 A 20100216; TW 201007842 A 20100216; TW I445085 B 20140711; US 2011031506 A1 20110210; US 2011031507 A1 20110210; US 8373176 B2 20130212; US 8395163 B2 20130312; WO 2009128382 A1 20091022; WO 2009128419 A1 20091022

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**EP 09731627 A 20090413**; CA 2721668 A 20090409; CA 2721671 A 20090413; CN 200980113242 A 20090409; CN 200980113300 A 20090413; EP 09732265 A 20090409; JP 2009057265 W 20090409; JP 2009057435 W 20090413; JP 2010508182 A 20090409; JP 2010508200 A 20090413; JP 2013254066 A 20131209; KR 20107022229 A 20090413; KR 20107022985 A 20090409; TW 98112360 A 20090414; TW 98112513 A 20090415; US 93743509 A 20090413; US 93745009 A 20090409